

Notice of References Cited	Application/Control No. 09/927,779		Applicant(s)/Patent Under Reexamination ROUKES ET AL.	
	Examiner Ann Y. Lam		Art Unit 1641	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,545,492	04-2003	Altmann et al.	324/754
*	B	US-6,289,717	09-2001	Thundat et al.	73/23.2
*	C	US-5,807,758	09-1998	Lee et al.	436/526
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Chui et al., "Independent detection of vertical and lateral forces with a sidewall-implanted dual-axis piezoresistive cantilever", Applied Physics Letters, Vol. 72, Number 11, March 1998, pp. 1388-1390.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.